IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicants

: Chandra V. Mouli and Ceredig Roberts

Serial No.

: 09/648,044

Filed

: August 25, 2000

Title

: METHOD AND DEVICE TO REDUCE GATE-INDUCED DRAIN

LEAKAGE (GIDL) CURRENT IN THIN GATE OXIDE MOSFETs

Docket

: MIO 0054 PA

Art Unit

: 2811

Assistant Commissioner for Patents

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

Washington, DC 20231

Sir:

Reg. No. 42,695

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §§ 1.56, 1.97, AND 1.98

Applicants submit herewith patents, publications, and other information of which they are aware, which they believe may be material, as defined in 37 CFR §1.56(b), to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR §1.56(a). While the information referred to in this Information Disclosure Statement may be material pursuant to 37 CFR §1.56(b), the filing of this Information Disclosure Statement is not intended to, pursuant to 37 CFR §1.97(h), constitute an admission that any patent, publication, or other information referred to is, or is considered to be, material to the patentability of this invention. Further, pursuant to 37 CFR §1.97(g), the filing of this Statement should not be construed as a statement that a search has been made or that no other material information exists.

A listing of all items of information cited is attached on PTO/SB/08A, a substitute for form 1449A/PTO. Copies of the items are enclosed for the convenience of the Examiner.

2800 MAIL ROOM

Serial No. 09/648,044 Docket No. MIO 0054 PA

This Information Disclosure Statement is being filed within the period set forth in 37 CFR §1.97(b) because it is believed to be filed before the mailing date of a first office action on the merits.

Respectfully submitted,

KILLWORTH, GOTTMAN, HAGAN & SCHAEFF, L.L.P.

Ву

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WAJ/mjt Encls.